

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kimihiro Mabuchi et al. Art Unit : Unknown
Serial No. : Examiner : Unknown
Filed : Herewith
Title : SEPARATION MEMBRANE WITH SELECTIVE PERMEABILITY AND
PROCESS FOR PRODUCING THE SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

Desig. ID No. AA (USP 6,432,309) corresponds to Desig. ID No. AH (JP 11-309355).

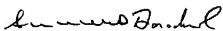
English language translations are attached for Desig. ID Nos. AE-AG and AI-AN.

The relevance of the references is indicated on the attached International Search Report.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 9/20/06



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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 19461-005US1	Application No.
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Kimihiro Mabuchi et al.	
		Filing Date Herewith	Group Art Unit
(37 CFR §1.98(b))			

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,432,309	08/13/2002	Fuke et al.			
	AB						
	AC						
	AD						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AE	2000-254222	09/19/2000	Japan			X	
	AF	2000-210544	08/02/2000	Japan			X	
	AG	2000-157852	06/13/2000	Japan			X	
	AH	11-309355	11/09/1999	Japan			See counter-part reference AA	
	AI	11-169690	06/29/1999	Japan			X	
	AJ	10-180058	07/07/1998	Japan			X	
	AK	07-289866	11/07/1995	Japan			X	
	AL	06-296686	10/25/1994	Japan			X	
	AM	06-165926	06/14/1994	Japan			X	
	AN	3551971	08/11/2004	Japan			X	

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AO	
	AP	
	AQ	
	AR	

Examiner Signature /Krishnan Menon/ (01/08/2009)	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Disclosure Form (PTO-1449)

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.M./